

## Letter of Authorization

**Shenzhen AtomStack Technologies Co., Ltd.**

**Company: Shenzhen AtomStack Technologies Co., Ltd.**

**Address: 17th Floor, Building 3A, Phase II, Intelligent Park, No. 76, Baohe Avenue, Shenzhen, China**

**Product Name: Laser Engraver**

**Model Number: Swift, Swift mini, Wand, Wand mini, A5 Pro, A5 V2, A5 Pro V2, A10 V2, A10 Pro V2, A20 Pro, A20 Pro V2, A40 Pro, A40 Pro V2, A5 V3, P3, P3 Pro, A7, G3, WM-LE001, WM-LE002, WM-LE003, WM-LE004, WM-LE005, WM-LE006, WM-LE007, WM-LE008, K3, K3 mini, K3 Pro, X5 Pro, X10 Pro, K40 Max, K70 Max**

**FCC Identifier: 2BC9I-SWIFT**

We authorize LGAI Technological Center S.A., Ronda de la Font del Carme, s/n, 08193 Bellaterra, Spain, to act on our behalf on all matters concerning the above named equipment.

Any individual within LGAI Technological Center S.A. is authorized to act on our behalf and take action on the application.

We declare that authorize LGAI Technological Center S.A., Ronda de la Font del Carme, s/n, 08193 Bellaterra, Spain, is allowed to forward all information related to the approval project to the Federal Communication Commission and to discuss any issues concerning the approval application. Any and all acts carried out by LGAI Technological Center S.A. on our behalf shall have the same effect as acts of our own.

**Name: Jason Li Date: September 2, 2025**

**Title: CEO**

**Signature of applicant:**

*Jason LI*